

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of: **Tsuyoshi YOSHITAKE**

Application Number: **Not yet assigned**
(§371 of international application No. PCT/JP2004/011543)

Filed: **April 7, 2006**

For: **FILM DEPOSITION APPARATUS HAVING HOLE-LIKE ROTARY FILTER PLATE FOR CAPTURING FINE PARTICLES, AND FILM DEPOSITION METHOD**

Attorney Docket Number: **062186**
Customer Number: **38834**

INFORMATION DISCLOSURE STATEMENT

Commissioner for Patents
P. O. Box 1450
Alexandria, VA 22313-1450

April 7, 2006

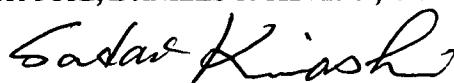
Sir:

In compliance with 37 C.F.R. §1.56, Applicant directs the attention of the Patent and Trademark Office to the documents listed on the attached PTO/SB/08. A copy of each non- U.S. document is enclosed herewith as well as an International Search Report mailed November 22, 2004.

If there are any fees due in connection with the filing of this paper, please charge Deposit Account No. 50-2866.

Respectfully submitted,

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Enclosure: PTO/SB/08, Documents (13) & Int'l Search Report

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Complete if Known

Combined Form PTO/SB/08A&B					
INFORMATION DISCLOSURE STATEMENT BY APPLICANT					
(use as many sheets as necessary)					
Sheet	1	of	1	Application Number	Not yet assigned
				Confirmation Number	
				Filing Date	April 7, 2006
				First Named Inventor	Tsuyoshi YOSHITAKE
				Art Unit	
				Examiner Name	
				Attorney Docket Number	062186

U.S. PATENT DOCUMENTS

Examiner Initials*	Cite No. ¹	Document Number		Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document
		Number	Kind Code ² (if known)		
	US				

FOREIGN PATENT DOCUMENTS

Examiner Initials*	Cite No. ¹	Foreign Patent Document			Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Translation ⁶
		Country Code ³	Number ⁴	Kind Code ⁵ (if known)			
1	JP	2003-49262			2/21/2003	Japan Science & Technology Corp	Abstract
2	JP	10-30169			2/3/1998	Mitsubishi Materials Corp	Abstract
3	JP	2003-277919			10/2/2003	Toyota Central Res & Dev Lab Inc	Abstract
4	JP	2003-73812			3/12/2003	Yamamoto Masaki and Mitsubishi Precision Co Ltd	Abstract
5	JP	6-17237			1/25/1994	Toyota Motor Corp et al.	Abstract
6	JP	7-166331			6/27/1995	Ko Ensei	Abstract
7	JP	2001-107225			4/17/2001	Japan Science & Technology Corp	Abstract
8	JP	8-176805			7/9/1996	Minolta Co Ltd	Abstract
9	JP	4-202762			7/23/1992	Hoya Corp and Murakami Koichi	Abstract
10	JP	10-30168			2/3/1998	Mitsubishi Materials Corp	Abstract
11	JP	2001-192811			7/17/2001	Canon Inc	Abstract

NON PATENT LITERATURE DOCUMENTS

Examiner Initials*	Cite No. ¹	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city, and/or country where published.	Translation ⁶
12		TSUYOSHI YOSHITAKE et al., "Droplet-Free Thin Films Prepared by Pulsed Laser Deposition...", Jpn.J.Appl.Phys. Vol. 41 (2002) pp.836-837	
13		E. V. PECHEN et al., "Pulsed-laser deposition of smooth high-T _c superconducting films using...", Appl.Phys.Lett. 1995 Vol. 66, No. 17, pp. 2292-2294	
14		International Search Report of International Application PCT/JP2004/011543 mailed November 22, 2004	

Examiner Signature	/Shamim Ahmed/ (06/09/2009)	Date Considered	06/09/2009
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*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

¹Applicant's unique citation designation number (optional). ²See Kind Codes of USPTO Patent Documents at www.uspto.gov, MPEP 901.04 or in the comment box of this document. ³ Enter Office that issued the document, by the two-letter code (WIPO Standard ST. 3). ⁴For Japanese patent documents, the indication of the year of the reign of the Emperor must precede the serial number of the patent document. ⁵Kind of document by the appropriate symbols as indicated on the document under WIPO Standard ST. 16 if possible. ⁶Applicant is to indicate here if English language Translation is attached.

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